

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/768,184	<b>Applicant(s)/Patent under Reexamination</b> TAKAHASHI, KAZUHIKO
	<b>Examiner</b> Ly D. Pham	<b>Art Unit</b> 2827

**SEARCHED**

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner